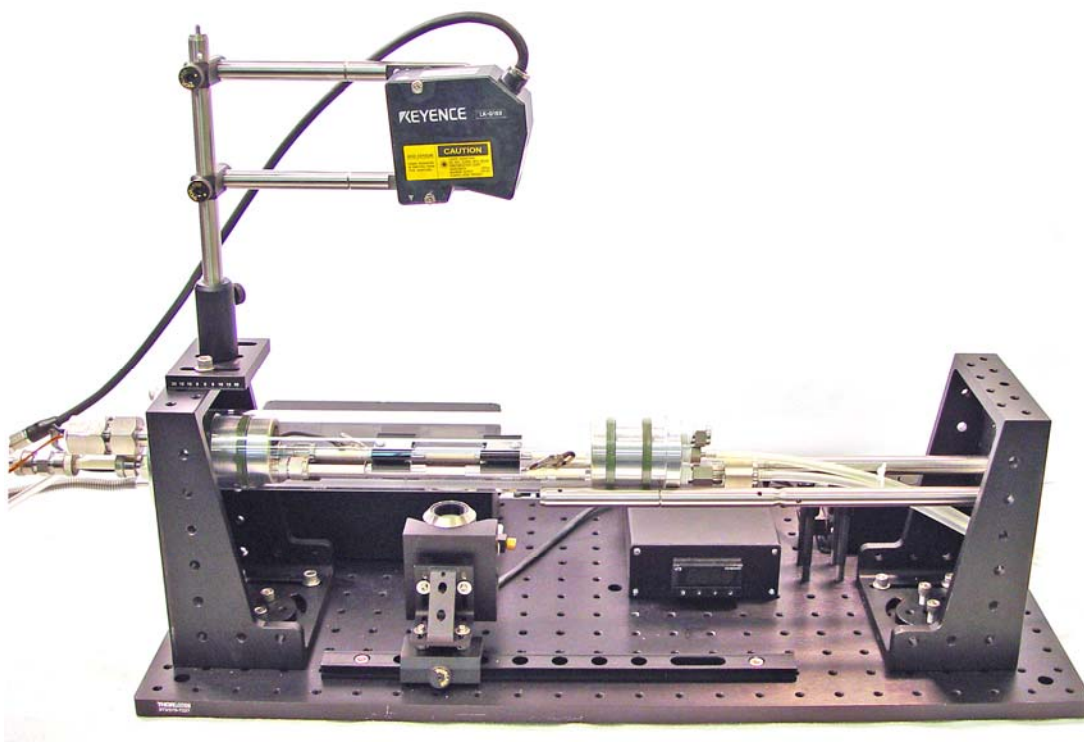


# SabreTube™

A Bench Top Thermal Processing System

**| NANO |**  
Absolute Nano

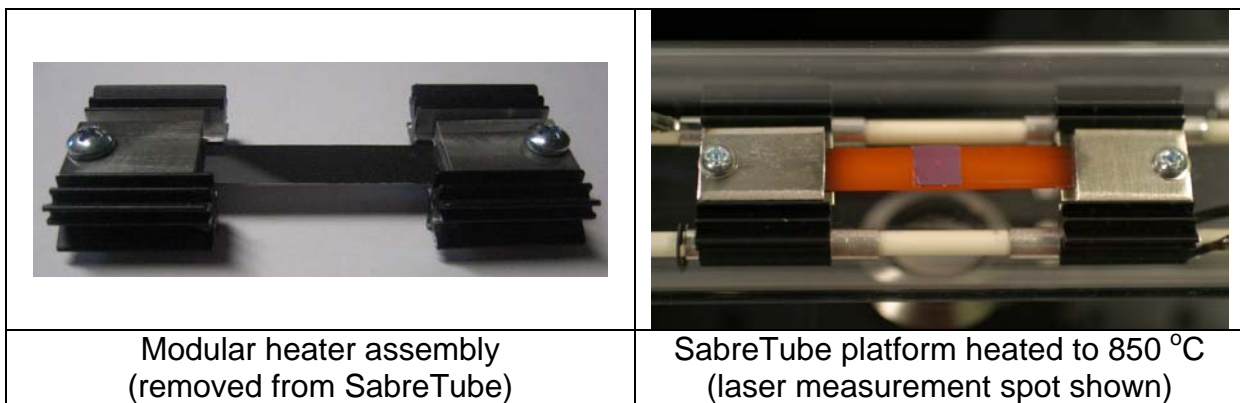


SabreTube™ Desktop Thermal Processing System  
(shown with optional laser displacement sensor; safety shield not shown)

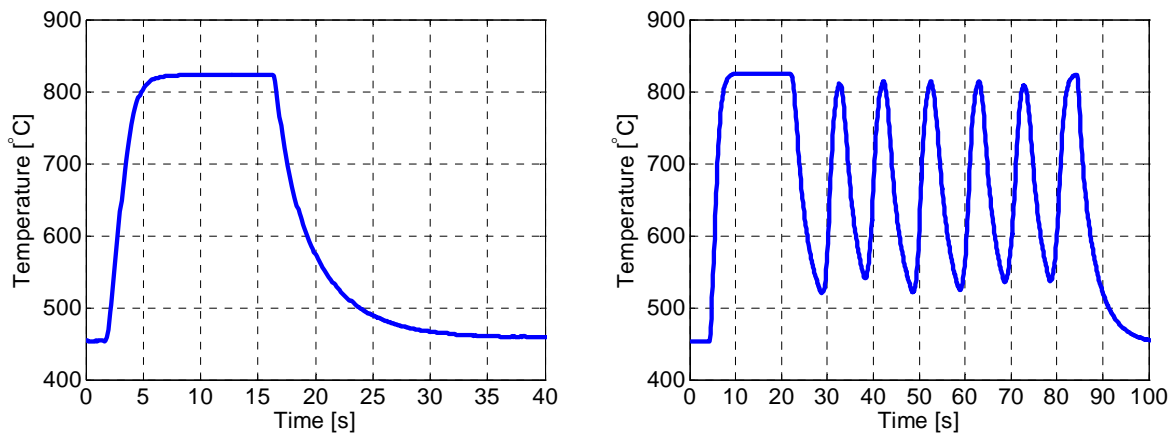
Absolute Nano introduces the SabreTube™ -- a unique tool for rapid development and testing of chemical vapor deposition and thermal annealing processes, such as growth of nanotubes/nanowires, curing of thin films, and thermal processing of microfabricated devices. It features 100°C/sec heating rates over a 1 cm wide substrate at up to 1000 °C, with full visual and instrument access. Sample exchanges in less than 1 minute, along with dynamic control and observation capabilities enable high-throughput innovation over wide process ranges.

## SabreTube Base Model Features

- A **small footprint** of 24"x12"x10" enables setup and operation in a small space on a desktop, lab bench, or in conjunction with another instrument, and easy storage in a standard cabinet. The unit is equipped with a **safety shield with interlocked safety switches**.
- A **modular resistive heater assembly** features a **replaceable silicon heating platform**. The process sample may be placed directly on the heating element, and the polished surface of the heater enables good thermal contact. The heating element is simply replaced using a screwdriver, and five replacement elements are included with the base model.



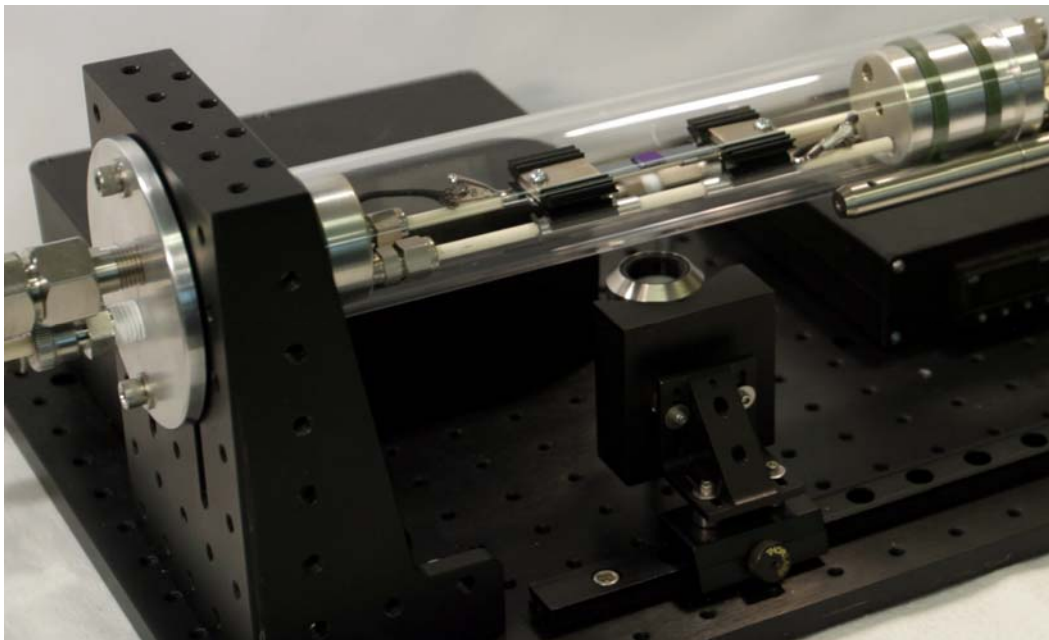
- The low thermal mass of the heated platform enables **rapid heating and passive cooling at rates of up to 100 °C/s, to 1000 °C**, under atmospheric conditions.



Rapid heating, cooling, and cycling

- The temperature measurement is non-contact using a **high-precision infrared sensor**, located outside and beneath the tube chamber. The sensor is mounted on a linear guide for easy positioning.

- The SabreTube quartz chamber is sealed by aluminum caps with concentric lip seals, and the seal geometry enables **atmospheric and low-pressure operation**, with no mechanical clamps or flanges. The standard input end cap contains a sealed bulkhead with a feedthrough for power transmission and a type K Thermocouple feedthrough.



View showing infrared sensor mounted on rail beneath tube, and output end cap with concentric lip seals (green)

- **Sample exchange is tool-free**; the tube retracts horizontally onto a pair of support rails, revealing the heated platform for full mechanical access.
- When chamber is closed, the **substrate is fully viewable for in situ optical observation**. The SabreTube baseplate and structural mounts have standard ¼"-20 threaded hole patterns for versatile user-specific mounting of additional components.
- The SabreTube can be powered by a **standard DC power supply** in current-regulated mode (user-supplied, 48V-12A recommended), or an optional closed-loop supply with integrated temperature control is also available.

## SabreTube Base Model Specifications

Base dimensions (width x depth)	24" x 12"
Heater power input (Current control strongly recommended)	0-48 VDC, 0-12A
Substrate material	Highly-doped silicon
Maximum substrate temperature	1000 °C
Maximum substrate heating rate	100 °C/s
Maximum substrate cooling rate (passive)	80 °C/s
Substrate size (included; width x length x thickness)	10 x 50 x 0.5 mm
Maximum substrate size (width x length x thickness)	10 x 100 x 2 mm
Infrared sensor output	K-type, 40 mV at 800 °C
Infrared sensor range	540-1370 °C
Tube diameter (ID x OD)	48 x 52 mm
Tube length	300 mm
Tube material	Fused quartz
Input gas connections	One 1/4" FNPT threaded hole One 1/8" FNPT threaded hole
Output gas connections	One 1/4" FNPT threaded hole One 1/8" FNPT threaded hole Check valve with 1/4" MNPT output
Base construction material	Anodized aluminum
End cap material	Aluminum
Seal material	Viton
Fitting and tubing material	Stainless steel
Internal support rail material	Alumina
Contact block materials	Aluminum, stainless steel

## Options and Accessories

- Closed-loop temperature controller with dedicated power supply and temperature display. Integrates directly with IR temperature sensor and furnace safety interlocks.
  - o Programmable with up to 16 ramp/soak segment temperature profiles.
  - o Available with RS232 or Ethernet communications port.
- Gas pre-heater assembly
  - o Also available with dedicated power delivery, integrated thermocouple, and temperature display.
- Laser displacement sensor for measuring real time film thickness and growth rates.
- Additional silicon heating elements.
- Additional heating element mounting brackets.
- Heating elements with SiO<sub>2</sub> insulating layer.
- Heating elements with type K thermocouple.

**For more information, please contact:**

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Wixom, MI

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## Ordering Information

Item	Part Number
SabreTube furnace	1100-00005
Integrated control system and power supply for SabreTube	2100-00010
Integrated control system and power supply for SabreTube, with RS 232 communications port	2100-00013
Integrated control system and power supply for SabreTube, with Ethernet communications port	2100-00014
Gas pre-heater assembly with integrated pre-heater control system and power supply	2100-00011
Gas pre-heater assembly with integrated pre-heater control system and power supply, with RS 232 communications port	2100-00015
Gas pre-heater assembly with integrated pre-heater control system and power supply, with Ethernet communications port	2100-00016
Laser displacement sensor with mounting hardware	2100-00017
Additional bare heating elements (package of five)	2200-00018
Heating elements with SiO <sub>2</sub> insulating layer on polished side (package of five)	2200-00020
Replacement heater mounting brackets with clamps (pair)	2200-00019
Heating element with integrated K-type fine-wire thermocouple (package of two)	2100-00021